In the claims:

Please substitute the following full listing of claims for the claims as originally filed or most recently amended.

1-21. (Canceled)

- 22. (Previously presented) An integrated circuit including
- a first layer having metal or metal alloy at a surface thereof,

a second layer adjacent to said surface having a metal or metal alloy via therein,

an interlayer connection between metal or metal alloy of said first layer and said metal or metal alloy via comprising a stable alloy region having graded mechanical characteristics, containing a predetermined quantity of alloying material and restricted to an interfacial region of said metal or metal alloy of said first layer and said metal or metal alloy via by a barrier layer,

wherein said metal alloy of said interlayer connection is formed as an annulus in said metal or metal alloy at a surface of said first layer.

23. (Currently Amended) The integrated circuit as recited in claim 21 22, wherein said via extends into said metal or metal alloy of said first layer surrounded by said annulus.